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## BIB DATA SHEET

CONFIRMATION NO. 4496

SERIAL NUMBER	FILING or 371(c) DATE	CLASS	GROUP ART UNIT	ATTORNEY DOCKET NO.		
10/539,569	08/18/2005	438	2895	124305		
<b>RULE</b>						
<b>APPLICANTS</b> Noriyoshi Sato, Miyagi, JAPAN; Takeshi Taniguchi, Tokyo, JAPAN; Hiroshi Mase, Ibaraki, JAPAN; Shuitsu Fujii, Hiroshima, JAPAN; Tamiya Fujiwara, Iwate, JAPAN;						
<b>** CONTINUING DATA *****</b> This application is a 371 of PCT/JP03/16887 12/26/2003						
<b>** FOREIGN APPLICATIONS *****</b> JAPAN 2002-379963 12/27/2002						
<b>** IF REQUIRED, FOREIGN FILING LICENSE GRANTED **</b> 05/16/2006						
Foreign Priority claimed	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No	<input type="checkbox"/> Met after Allowance	STATE OR COUNTRY	SHEETS DRAWINGS	TOTAL CLAIMS	INDEPENDENT CLAIMS
35 USC 119(a-d) conditions met	<input type="checkbox"/> Yes <input checked="" type="checkbox"/> No		JAPAN	18	21	8
Verified and	/CARIDAD EVERHART/ Examiner's signature	Initials				
Acknowledged						
<b>ADDRESS</b> OLIFF & BERRIDGE, PLC P.O. BOX 320850 ALEXANDRIA, VA 22320-4850 UNITED STATES						
<b>TITLE</b> Plasma generator, ozone generator, substrate processing apparatus and manufacturing method of semiconductor device						
<b>FILING FEE RECEIVED</b> 2080	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:			<input type="checkbox"/> All Fees		
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